

1.1.1.3 Special Photodiode Sensors

3μW to 1W

Features

- PD300-MS for measurement of optical intensity after the microscope objective.
- Low angular dependence for high N.A. objectives.
- Can be used with air, water or oil immersion objectives.

PD300-MS



Model	PD300-MS	
Use	Measurement of light intensity at microscope slide plane	
Detector Type	Silicon with filter	
Aperture	18x18mm	
Spectral Range nm	350-1100	
Power Range	3μW to 1W (see wavelength dependency below)	
Power Scales	100μW to 1W and dBm	
Resolution μW	0.1	
Calibration Uncertainty ±%	1.1 430-1000nm ^(b)	
Maximum Power vs. Wavelength	Wavelength, nm	Power Range
	350 - 650	6μW to 1W
	650 - 800	3μW to 800mW
	800 - 1000	3μW to 600mW
Accuracy (including errors due to temp. variations)	>1000	6μW to 700mW
% error vs Wavelength nm ^(a)	±7 350 - 400	
	±5 400 - 1100	
Linearity	1%	
Additional Error with Converging Beam	3% for N.A. 0.9	
Damage Threshold W/cm ²	20	
Noise Level	300nW at 350nm, 150nW at 960nm	
Response Time with Meter s	0.2	
Compliance	CE, UKCA, China RoHS	
Version		
Part Number	7Z02482	

Note: (a) For beam centered on sensor ±2 mm
(b) For calibration uncertainty of wavelengths outside of this range see table on page 25

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